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Type of Paper transmitted: Comments on Reasons for Allowance

Applicant's Name: Toshiharu YANAGIDA

Serial No. (Control No.): 09/915,160 Examiner: Junghwa M. IM

Filing Date: July 25, 2001 Art Unit: 2811

Application Title: SEMICONDUCTOR APPARATUS AND PROCESS OF PRODUCTION THEREOF

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In re Patent Application of:

Toshiharu YANAGIDA

Group Art Unit: 2811

Application No.: 09/915,160

Examiner: Junghwa M. Im

Filed: July 25, 2001

Confirmation No.: 7228

For: Semiconductor Apparatus and
Process of Production Thereof

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMENTS ON REASONS FOR ALLOWANCE

Although the reasons for allowance provided during prosecution are factually correct, Applicants believe the reasons do not set forth all the distinctions between the claims of the present application and the prior art.

Dated: 03/10/06

By:



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